



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Brosnihan et al.

GROUP: 2841

SERIAL NO: 09/921,456

EXAMINER: Unknown

FILED: August 3, 2001

FOR: BONDED WAFER OPTICAL MEMS PROCESS

Assistant Commissioner of Patents
Washington, D.C. 20231

Sir:

RESPONSE

In response to the Restriction Requirement mailed December 14, 2004, Applicant elects to prosecute Claims 1-22, drawn to a method of fabricating a microelectromechanical system.

Examination on the merits is respectfully requested.

Respectfully submitted,

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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Sarah E. Kennedy

Date: 12/29/04